



IFW

PATENT  
Attorney Docket No. 5168-74

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of: )  
)  
Kazuaki Yoshida ) Group Art Unit: To be Assigned  
)  
Application No.: 10/593,147 ) Examiner: To be Assigned  
)  
Filed: September 18, 2006 )  
)  
For: Polishing Composition and ) Confirmation No.: To be Assigned  
Polishing Method )

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**INFORMATION DISCLOSURE STATEMENT**

Enclosed for the consideration of the Examiner in connection with the prosecution of this case is a copy of six published Japanese patent applications and article set forth on the attached Form PTO/SB/08. Please refer to the abstracts in English for the relevance of each of the Japanese applications.

If there is any fee due in connection with the filing of this Statement, please charge such fee to our deposit account 06-0916.

Respectfully submitted,

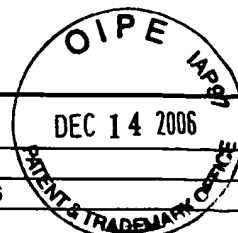
FINNEGAN, HENDERSON, FARABOW,  
GARRETT & DUNNER, L.L.P.

Dated: December 14, 2006

By: 

Arthur S. Garrett  
Reg. No. 20,338  
Tel: 202 408 4091

IDS Form PTO/SB/08: Substitute for form 1449A/PTO  <h2 style="text-align: center;">INFORMATION DISCLOSURE STATEMENT BY APPLICANT</h2> <p style="text-align: center;">(Use as many sheets as necessary)</p>			<b>Complete if Known</b>		
			Application Number	10/593,147	
			Filing Date	September 18, 2006	
			First Named Inventor	Kazuaki Yoshida	
			Art Unit	To be Assigned	
			Examiner Name	To be Assigned	
			Attorney Docket Number	5168-74	
Sheet	1	of	2		



U.S. PATENTS AND PUBLISHED U.S. PATENT APPLICATIONS					
Examiner Initials <sup>1</sup>	Cite No. <sup>1</sup>	Document Number	Issue or Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number-Kind Code <sup>2</sup> (if known)			
		US-			
		US-			
		US-			
		US-			
		US-			
		US-			
		US-			
		US-			
		US-			
		US-			
		US-			
		US-			
		US-			

**Note:** Submission of copies of U.S. Patents and published U.S. Patent Applications is not required.

FOREIGN PATENT DOCUMENTS						
Examiner Initials <sup>1</sup>	Cite No. <sup>1</sup>	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	Translation <sup>6</sup>
		Country Code <sup>3</sup> Number <sup>4</sup> Kind Code <sup>5</sup> (if known)				
		JP 2000-8024	01-11-2000	Tanaka Hiroaki		X-Abstract
		JP 2001-93866	04-06-2001	Speedfam Co. Ltd.		X-Abstract
		JP 2004-203638	07-22-2004	Ube Nitto Kasei Co.; Tytemn Corp.		X-Abstract
		JP 2003-226865	08-15-2003	EKC Technology KK		X-Abstract
		JP 11-214338	08-06-1998	Memc KK		X-Abstract
		JP 11-60232	03-02-1999	ISO Mamoru		X-Abstract

NON PATENT LITERATURE DOCUMENTS			
Examiner Initials <sup>1</sup>	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	Translation <sup>6</sup>
		U. MAHAJAN ET AL., "Dynamic Lateral Force Measurements during Chemical Mechanical Polishing of Silica," Electrochemical and Solid-State Letters, 2 (2) 80-82 (1999)	

Examiner Signature		Date Considered	
--------------------	--	-----------------	--

1231220\_1